

SEP 27 2004

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 09/233,377
Confirmation No. 7580
Filing Date January 18, 1999
Inventor..... Gurtej S. Sandhu et al.
Assignee..... Micron Technology, Inc.
Group Art Unit..... 2813
Examiner Pham, Thanhha S.
Attorney's Docket No. MI22-1114
Customer No. 021567
Title: Method of Forming a Refractory Metal Silicide

RESPONSE TO JUNE 28, 2004 OFFICE ACTION

To: Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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AMENDMENTS

In response to the Office Action of June 28, 2004, applicant amends and remarks as follows.